



10-31-05

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	PATENT APPLICATION
	)	
Inventors: Yoshi Ono	)	
	)	Attorney Docket No.
Serial No.: 10/602,194	)	SLA0669
	)	
Filed: June 23, 2003	)	Group No. 2823
	)	
Title: LOW TEMPERATURE	)	Examiner: Khiem D. Nguyen
NITRIDATION OF SILICON	)	
	)	Confirmation No. 9996

Commissioner for Patents  
P. O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

ASSOCIATE POWER OF ATTORNEY  
CHANGE OF CORRESPONDENCE ADDRESS

I hereby appoint Robert D. Varitz of 4915 S.E. 33<sup>rd</sup> Place, Portland, Oregon 97202, U. S. Patent and Trademark Office Registration Number 31436, as an associate attorney for the above-captioned matter, with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

Please change the Correspondence Address to that associated with Customer Number 55,376.

Date:

10/25/05

Respectfully submitted,

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